## Notice of References Cited Application/Control No. 10/580,767 Examiner OMAR F. FERNANDEZ RIVAS Applicant(s)/Patent Under Reexamination LOCK ET AL. Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,782,377	08-2004	Agarwal et al.	706/47
*	В	US-7,353,214	04-2008	Yamanishi et al.	706/46
*	С	US-5,222,197	06-1993	Teng et al.	706/58
*	D	US-2002/0161711	10-2002	Sartor et al.	705/51
*	Е	US-7,089,592	08-2006	Adjaoute, Akli	726/25
	F	US-			
	G	US-			
	Ι	US-			
	-	US-			
	7	US-			
	K	US-			
	┙	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.